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INFORMATION DISCLOSURE STATEMENT
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Art Unit	

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U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
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Examiner's Initials*	Cite No. (optional)	Country	Number	Publication Date	Name of Applicant or Patentee
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		Goessl et al., "Plasma lithography — thin-film patterning of polymers by RF plasma
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